



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

**\*BIBDATASHEET\*****CONFIRMATION NO. 4723**

Bib Data Sheet

SERIAL NUMBER 10/787,436	FILING DATE 02/27/2004  RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 500.38899VX3
-----------------------------	---------------------------------------	--------------	------------------------	--

## APPLICANTS

Naoki Yamamoto, Kawaguchi, JAPAN;

**\*\* CONTINUING DATA \*\*\*\*\***


This application is a DIV of 10/448,351 05/30/2003 PAT 6,727,132  
 which is a DIV of 10/272,369 10/17/2002 PAT 6,645,799  
 which is a DIV of 09/639,306 08/16/2000 PAT 6,503,788

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

JAPAN 2000-17875 01/24/2000

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

**\*\* 05/15/2004**

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance  Examiner's Signature Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 7	TOTAL CLAIMS 15	INDEPENDENT CLAIMS 3
--	---	------------------------------	------------------------	-----------------------	----------------------------

## ADDRESS

020457  
 ANTONELLI, TERRY, STOUT & KRAUS, LLP  
 1300 NORTH SEVENTEENTH STREET  
 SUITE 1800  
 ARLINGTON, VA  
 22209-9889

## TITLE


Method of manufacturing a dual gate semiconductor device with a poly-metal electrode

FILING FEE

RECEIVED  
770

FEES: Authority has been given in Paper  
 No. \_\_\_\_\_ to charge/credit DEPOSIT ACCOUNT  
 No. \_\_\_\_\_ for following:

- ☐ All Fees  
☐ 1.16 Fees ( Filing )  
☐ 1.17 Fees ( Processing Ext. of time )  
☐ 1.18 Fees ( Issue )  
☐ Other \_\_\_\_\_  
☐ or "

 Credit